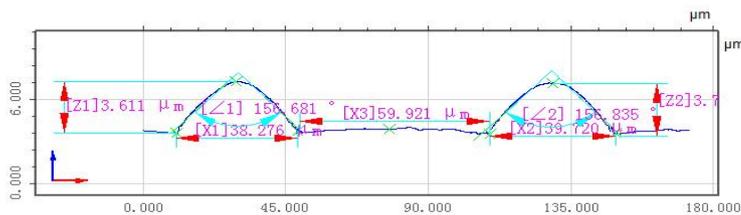
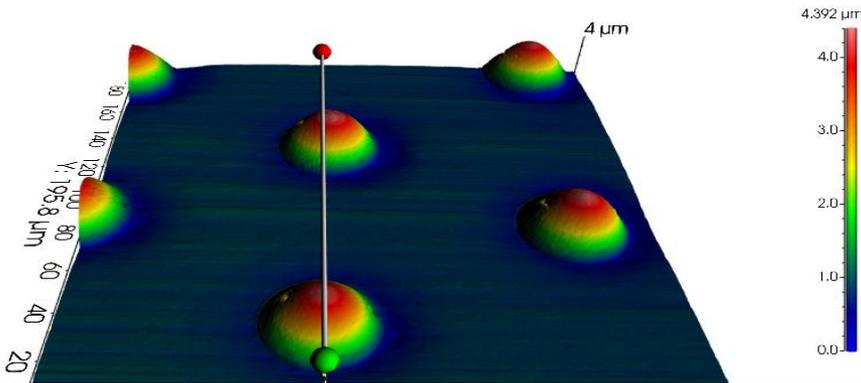
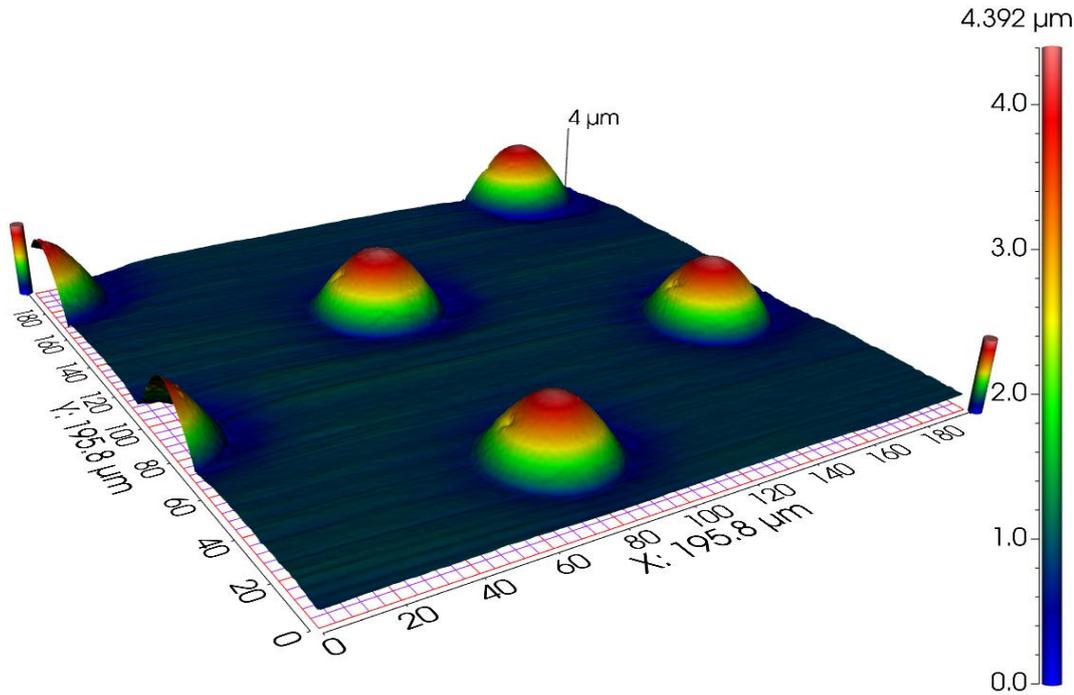


매개 변수;

1. 광학 시스템: 접안 렌즈 0.5x+ 간섭 대물 렌즈 50x+100W 카메라;
2. 시야 크기: 196x196 $\mu\text{m}$ ;
3. 테스트 샘플: 마이크로 나노 구조;
4. 테스트 매개변수: 윤곽선 크기;
5. 데이터 분석: 레벨링, 프로파일 추출, 윤곽 분석

범프 구조



项目	测量值
[X1]	38.276 $\mu\text{m}$
[X2]	39.720 $\mu\text{m}$
[X3]	59.921 $\mu\text{m}$
[Z1]	3.611 $\mu\text{m}$
[Z2]	3.759 $\mu\text{m}$
[Z1]	156.681 $^\circ$
[Z2]	156.835 $^\circ$

放大

缩小

100%

全选

反选

X放大

X缩小

Y放大

Y缩小

删除

锁定纵横比

特征创建

标注创建

坐标系

水平

垂直

距离

半径

直径

角度

X夹角

Y夹角

坐标

坐标差

直线度

圆度

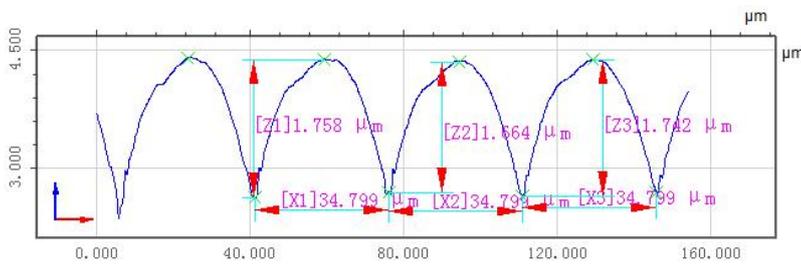
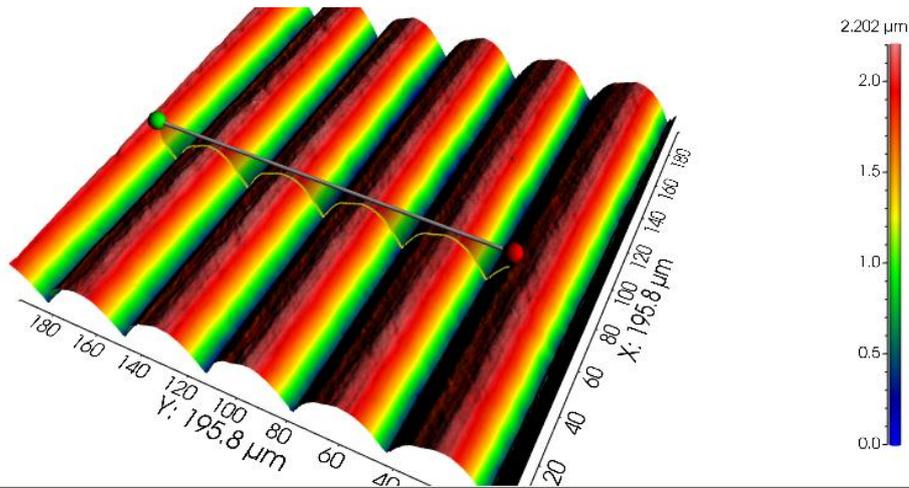
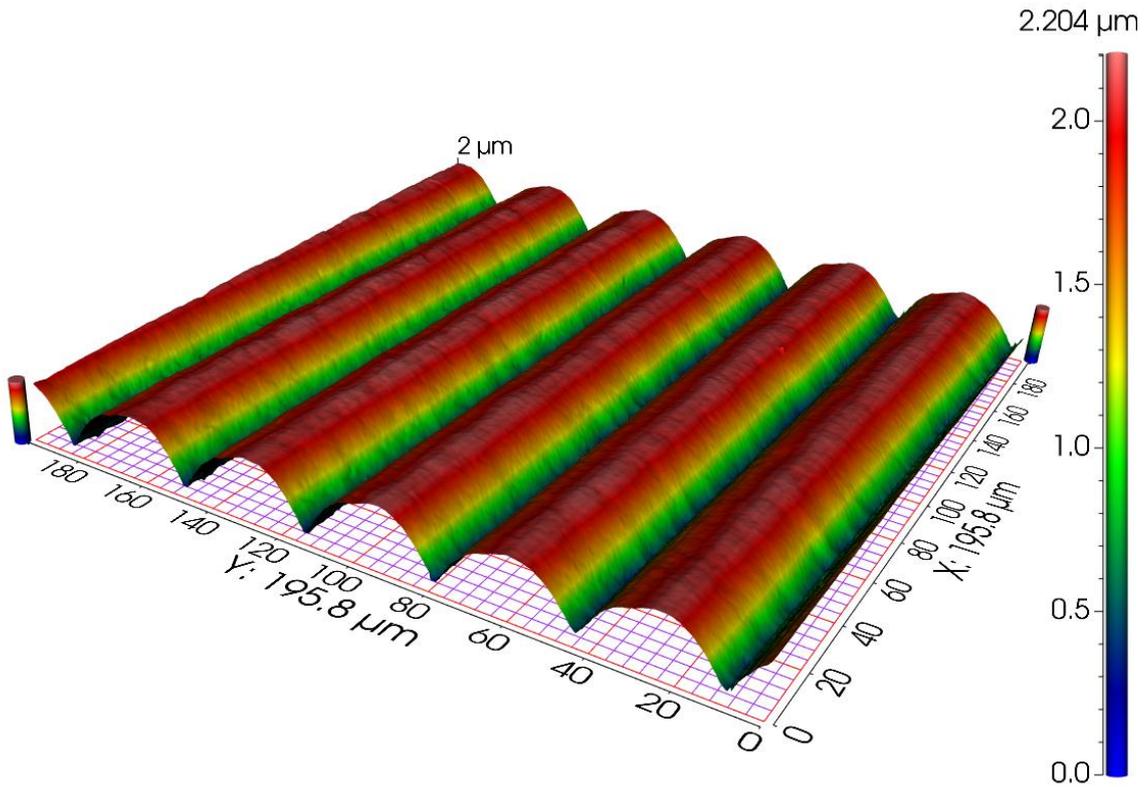
平行度

垂直度

位置度

> 请选择第一条直线或右键结束

원통형 아크 구조



Navigation and editing tools:

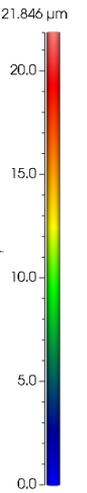
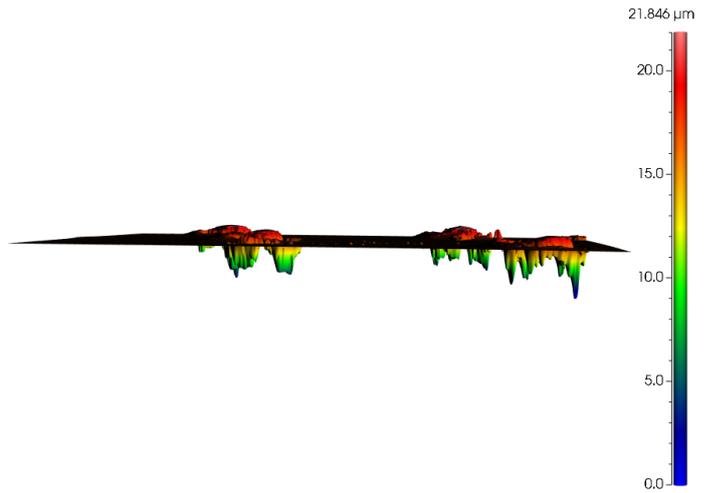
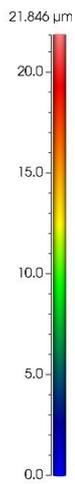
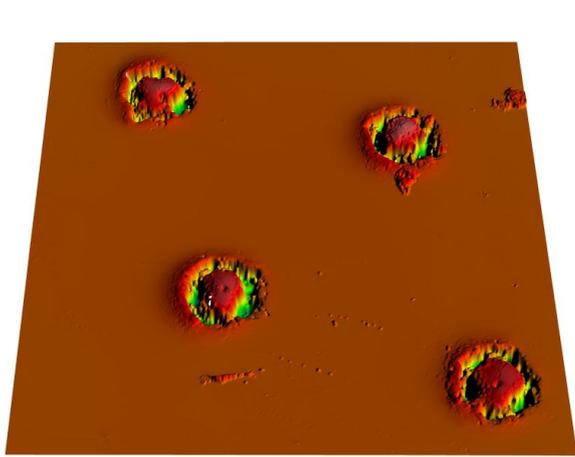
- 放大 (Zoom In)
- 缩小 (Zoom Out)
- 100%
- ALL (Select All)
- 反选 (Inverse Select)
- X放大 (Zoom In X)
- X缩小 (Zoom Out X)
- Y放大 (Zoom In Y)
- Y缩小 (Zoom Out Y)
- 删除 (Delete)
- 锁定纵横比 (Lock Aspect Ratio)

Feature and Annotation Creation Tools:

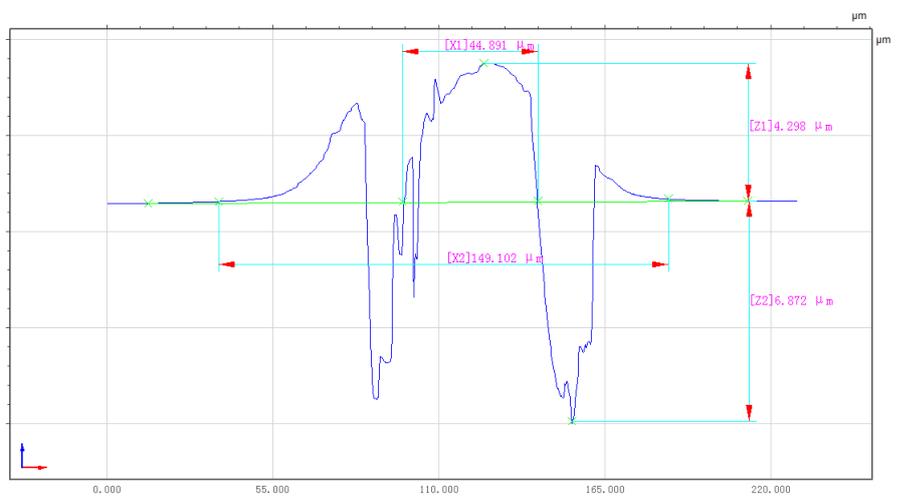
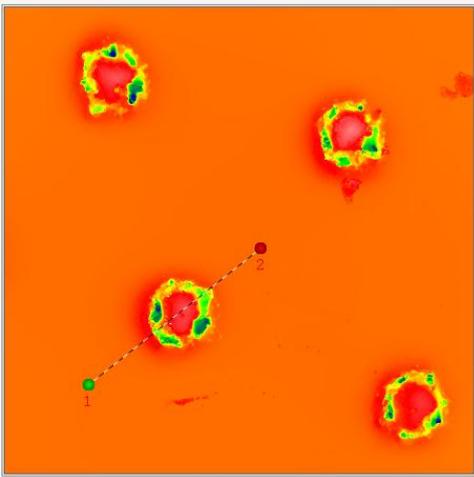
- 特征创建 (Feature Creation): 水平 (Horizontal), 垂直 (Vertical), 距离 (Distance), 半径 (Radius), 直径 (Diameter)
- 标注创建 (Annotation Creation): 角度 (Angle), X夹角 (X-Angle), Y夹角 (Y-Angle), 坐标 (Coordinate), 坐标差 (Coordinate Difference)
- 坐标系 (Coordinate System): 直线度 (Straightness), 圆度 (Circularity), 平行度 (Parallelism), 垂直度 (Perpendicularity), 位置度 (Position)

项目	测量值
[X1]	34.799 μm
[X2]	34.799 μm
[X3]	34.799 μm
[Z1]	1.758 μm
[Z2]	1.664 μm
[Z3]	1.742 μm

# 마이크로나노 피트 등고선 크기 측정



表面 :



表面 :

